

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109375		APPLICATION NO. 09/865,468	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT(S) Hisao YASUHARA et al.			
				FILING DATE May 29, 2001		GROUP 1744	

OIPE
DEC 27 2001
PATENT & TRADEMARK OFFICE

U.S. PATENT DOCUMENTS						
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
		4,845,041	7/1989	Scuitto et al.		
		4,031,424	6/1977	Penfold et al.		
		4,434,042	2/1984	Keith		

FOREIGN PATENT DOCUMENTS						
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
		GB 2101638 A	1/1983	Great Britain		

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)		
		Shevchenko N. B. et al., "Granular Thin Film Deposition by Simultaneous Spark Erosion and Sputtering", Journal of Applied Physics, American Institute of Physics, New York, vol. 81, No. 8, Part 2B, 15 April 1997, pages 5564-5566.

RECEIVED
DEC 28 2001
TC 1700

EXAMINER 	DATE CONSIDERED 12/6/01
--------------	----------------------------

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

[illegible]